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Bib Data Sheet

CONFIRMATION NO. 3573

SERIAL NUMBER 09/917,842	FILING DATE 07/27/2001 RULE	CLASS 700	GROUP ART UNIT 2125	ATTORNEY DOCKET NO. 5017/ISM/CORE MCVD/SB
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** CONTINUING DATA *****

** FOREIGN APPLICATIONS *****

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 09/03/2001

Foreign Priority claimed 35 USC 119 (a-d) conditions met Verified and Acknowledged	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after Allowance Examiner's Signature <i>[Signature]</i> Initials <i>ASR</i>	STATE OR COUNTRY CA	SHEETS DRAWING 4	TOTAL 50 CLAIMS 11	INDEPENDENT 7 CLAIMS 3
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ADDRESS

32588

APPLIED MATERIALS, INC.

2881 SCOTT BLVD. M/S 2061

SANTA CLARA, CA

95050

TITLE

Atomic layer deposition apparatus

FILING FEE	FEES: Authority has been given in Paper	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of
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